



BTW

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re U.S. Patent Application of )  
)  
**TSUCHIYAMA et al.** )  
)  
Application Number: 10/820,782 )  
)  
Filed: April 9, 2004 )  
)  
For: **MANUFACTURING METHOD OF SEMICONDUCTOR** )  
**DEVICE, AUTOMATIC OPERATION METHOD AND** )  
**AUTOMATION OPERATION SYSTEM OF** )  
**SEMICONDUCTOR MANUFACTURING APPARATUS,** )  
**AND AUTOMATIC OPERATION METHOD OF CMP** )  
**APPARATUS** )  
)  
ATTORNEY DOCKET NO. TSUT.0029 )

**Honorable Assistant Commissioner for Patents**  
**Washington, D.C. 20231**

**LETTER**

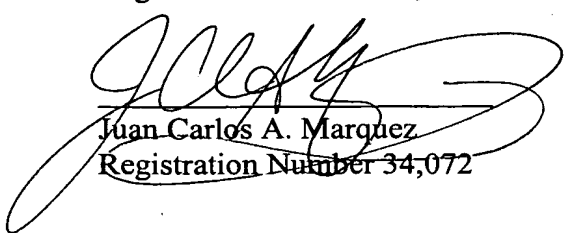
Sir:  
The below-identified communications are submitted in the above-captioned application or proceeding:

- |   |                           |   |
|---|---------------------------|---|
| <input checked="" type="checkbox"/> (X) | Priority Documents (1)    |   |
| <input checked="" type="checkbox"/> (X) | Request for Priority      | <input type="checkbox"/> ( ) Assignment Document              |
| <input type="checkbox"/> ( )            | Response to Missing Parts | <input type="checkbox"/> ( ) Petition under 37 C.F.R. 1.47(a) |
|   | w/ signed Declaration     | <input type="checkbox"/> ( ) Check for \$130.00               |

☒ [X] The Commissioner is hereby authorized to charge payment of any fees associated with this communication, including fees under 37 C.F.R. § 1.16 and 1.17 or credit any overpayment to **Deposit Account Number 08-1480**. A duplicate copy of this sheet is attached.

Respectfully submitted,

\_\_\_\_\_  
Stanley P. Fisher  
Registration Number 24,344

  
\_\_\_\_\_  
Juan Carlos A. Marquez  
Registration Number 34,072

**REED SMITH LLP**  
3110 Fairview Park Drive  
Suite 1400  
Falls Church, Virginia 22042  
(703) 641-4200  
July 14, 2004



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**In re U.S. Patent Application of**

**TSUCHIYAMA et al.**

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DEVICE, AUTOMATIC OPERATION METHOD AND  
AUTOMATION OPERATION SYSTEM OF  
SEMICONDUCTOR MANUFACTURING APPARATUS,  
AND AUTOMATIC OPERATION METHOD OF CMP  
APPARATUS**

**ATTORNEY DOCKET NO. TSUT.0029**

**Honorable Assistant Commissioner  
for Patents  
Washington, D.C. 20231**

**REQUEST FOR PRIORITY  
UNDER 35 U.S.C. §119  
AND THE INTERNATIONAL CONVENTION**

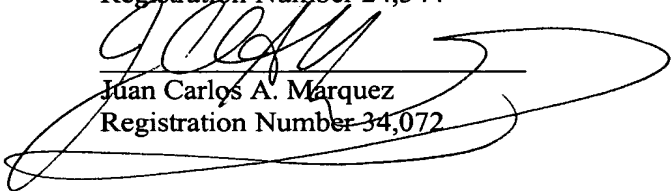
**Sir:**

In the matter of the above-captioned application for a United States patent, notice is hereby given that the Applicant claims the priority date of April 11, 2003, the filing date of the corresponding Japanese patent application 2003-107658.

The certified copy of corresponding Japanese patent application 2003-107658 is being submitted herewith. Acknowledgment of receipt of the certified copy is respectfully requested in due course.

Respectfully submitted,

\_\_\_\_\_  
Stanley P. Fisher  
Registration Number 24,344

  
\_\_\_\_\_  
Juan Carlos A. Marquez  
Registration Number 34,072

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